



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Yasuhisa Ishikawa et al. Conf. No.: 3907  
Serial No.: 10/658,781 Group Art Unit: 2815  
Filed: September 10, 2003 Examiner: E. Lee  
For: ELECTROSTATIC DISCHARGE SEMICONDUCTOR PROTECTION  
CIRCUIT OF REDUCED AREA (As Amended)

Commissioner for Patents  
United States Patent and Trademark Office  
P. O. Box 1450  
Alexandria, Virginia 22313-1450

## AMENDMENT UNDER 37 C. F. R. §1.312

Sir:

In response to the Notice of Allowance mailed  
March 25, 2005, please amend the above-identified  
application as follows:

Amendments to the specification begin on page  
2 of this paper.

A complete listing of claims begins on page 3  
of this paper. No amendments to the  
claims are presented.

Remarks begin on page 6 of this paper.

*04 enter amendment*

*MDR*  
8/8/05